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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813
Examiner: Jack S. J. Chen

In Re PATENT APPLICATION of:

Applicant(s): Toshikazu MIZUKOSHI

Serial No.: 10/635,506

Filed: August 7, 2003

For: METHOD OF FABRICATING A
SEMICONDUCTOR DEVICE TRENCH
HAVING AN OXIDE FILM ON A
CORNERED PORTION THEREOF

Atty. Dkt.: OKI 361

**RESPONSE TO
NOTICE OF
NON-COMPLIANT
AMENDMENT**

September 22, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment (37 CFR 1.111) mailed on September 20, 2005, which states that in the Amendment filed on June 27, 2005, Applicant fails to indicate whether the new added claims 11-15 read on the original elected species I, please find attached hereto a revised Amendment, which complies with 37 CFR 1.136(a).

Respectfully submitted,

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September 22, 2005
Date

RHB:vm



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AMENDMENT

September 22, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on April 20, 2005, please
amend the above-identified application as follows: